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| SERIAL NUMBER 10/521,035 | FILING OR 371(c) DATE 08/02/2005 RULE | CLASS 117 | GROUP ART UNIT 1765 | ATTORNEY DOCKET NO. JG-SU-5207PCT/US 500577.2 |
| APPLICANTS Daisuke Wakabayashi, Tokyo, JAPAN; Masao Saito, Tokyo, JAPAN; Satoshi Sato, Tokyo, JAPAN; Jun Furukawa, Tokyo, JAPAN; Kounosuke Kitamura, Tokyo, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08577 07/07/2003 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2002-197140 07/05/2002 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 15 | TOTAL CLAIMS 6 |
| Examiner's Signature <i>[Signature]</i> Initials <i>F.H.</i> | | INDEPENDENT CLAIMS 3 | | |
| ADDRESS 26418 | | | | |
| TITLE Method of producing silicon monocrystal | | | | |
| FILING FEE RECEIVED 1390 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |